



RCE 2814
PATENT APPLICATION

Date July 11, 2002

In re the Application of

Hiroyuki ABE et al.

Group Art Unit: 2814

Application No.: 08/930,449

Examiner: S. Rao

Filed: October 7, 1997

Docket No.: JAO 39514

For: HIGH ENERGY SUPPLY APPARATUS, METHOD OF FORMING CRYSTALLINE FILM
AND METHOD OF MANUFACTURING THIN FILM ELECTRONIC DEVICE

**LARGE ENTITY PETITION FOR 1st - 3rd EXTENSION
OF TIME UNDER 37 C.F.R. §1.136(a) AND
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

Transmitted herewith is a Request for Continued Prosecution in the above-identified patent application. The shortened statutory period having expired June 11, 2002, an extension of time for a period of one month is hereby requested. Attached hereto is our Check No. 132424 in the amount of \$110.00 in payment for:

 X Extension fee for response within first month pursuant to §1.136(a) (\$110.00)
 Extension fee for response within second month pursuant to §1.136(a) (\$400.00)
 Extension fee for response within third month pursuant to §1.136(a) (\$920.00)

The Director is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

Respectfully submitted,


James A. Oliff
Registration No. 27,075

David M. Lafkas
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~~01 FC:179~~
02 FC:115

~~740.00 DP~~
110.00 DP

JAO:DML/rxg

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DEPOSIT ACCOUNT USE
AUTHORIZATION
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